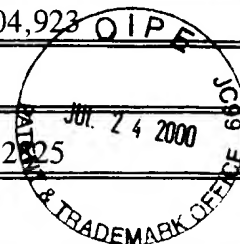


INFORMATION DISCLOSURE CITATION PTO-1449	Atty. Docket No. 000155	Serial No. 09/504,923
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	Filing Date: February 16, 2000	Group Art Unit: 2825



### U.S. PATENT DOCUMENTS

Examiner Initial	Document No.	Name	Date	Class	Subclass	Filing Date (If appropriate)
_____	AA					
_____	AB					
_____	AC					
_____	AD					
_____	AE					

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### FOREIGN PATENT DOCUMENTS

Document No.	Date	Country	Translation (Yes or No)
<u>NB</u> AF 6-283532	7/10/94	Japan	Abstract
<u>NB</u> AG EP 0 536 664	4/14/93	Europe	Yes
<u>NB</u> AH EP 0 840 363	5/6/98	Europe	Yes
<u>NB</u> AI WO 98/33950	8/6/98	PCT	Yes
<u>NB</u> AJ WO 96/17104	6/6/96	PCT	Yes
<u>→</u> <del>AK DE 35 22 427</del>	<del>2/20/86</del>	<del>German</del>	<del>No</del>

*Insufficient statement of Relevance*

### OTHER DOCUMENTS

<u>NB</u>	AL	<p>"MOCVD of TiN and /or Ti from New Precursors," Jaegab Lee et al.  <u>Thin Solid Films</u> SH, Elsevier-Sequoia S.A. Lausanne. vol. 320, no. 1, 4 May 1998 (1998-05-04), pages 15-19, XP000668459 ISSN: 0040-6090.</p>
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Examiner

*Neal Berermy*

Date Considered

*11/17/01*